

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of :
Won-suk Yang et al. : Group Art Unit: 2814
Application No. 09/313,659 : Examiner: Kalam, Abul
Filed May 18, 1999 : Confirmation No. 4199

MULTILAYER INTERCONNECTION STRUCTURE OF A SEMICONDUCTOR

AMENDMENT

U.S. Patent and Trademark Office
E-FILING
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

In response to the Office Action dated July 21, 2010, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.